

In the Specification

Please replace the corresponding paragraphs in Applicant's specification with the following substitute paragraphs:

Page 1, paragraph 1

[0001] This application claims priority under 35 U.S.C. §119(e) from U.S. Patent Application serial No. [[____]] 10/032,198 entitled "Multi-Axis Micro-Electro-Mechanical Actuator," by Vlad J. Novotny and Yee-Chung Fu, filed on December [[19]] 20, 2001, U.S. Patent Application serial No. 09/865,981 entitled "Optical Cross Connect Switching Array System With Optical Feedback," by Vlad J. Novotny, filed on May 24, 2001, and U.S. Patent Application serial No. 60/206,744, entitled "Optical Cross Connect Switching Array Systems With Optical Feedback Control," by Vlad J. Novotny, filed May 24, 2000. This application additionally relates to U.S. Patent Application serial No. [[____]] 10/028,657 entitled "Pattern-Transfer Process for Forming Micro-Electro-Mechanical Structures," by Vlad J. Novotny, filed [[herewith]] December 21, 2001. Each of the above-identified documents is incorporated herein by reference.

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[0072] Finally, the structure of Figure 64 is subjected to a silicon-dioxide etch to remove oxide layers 5300 and 5310, and to remove those portions of oxide layer 5020 that connect adjacent elements depicted in the cross section of Figure 65. Though not shown, a reflective surface is then

added to silicon layer $[[3410]]$ 5025. The completed actuator is annotated using some of the numbers introduced in Figures 1A and 1B to identify the actuator structures shown in the cross section. As with the previous example of Figure 32, the cross section of Figure 65 differs slightly from what would be obtained along line A-A' of Figures 1A and 1B. What remains of silicon layer 5005 provides the actuator support.